

Notice of References Cited

Application/Control No.

09/392,865

Applicant(s)/Patent Under
Reexamination
KITAMURA ET AL.

Examiner

Thien F Tran

Art Unit

2811

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
	A	US-5434093-	07-1995	Chau et al.	438	300
	B	US-5518945-	05-1996	Bracchitta et al.	438	307
	C	US- -				
	D	US- -				
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	G	US- -				
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	I	US- -				
	J	US- -				
	K	US- -				
	L	US- -				
	M	US- -				

FOREIGN PATENT DOCUMENTS

*		Document Number	Date	Country	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY				
	N	- -					
	O	- -					
	P	- -					
	Q	- -					
	R	- -					
	S	- -					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Nitride Sidewall Sapcers Used As a Contamination Barrier, IBM Technicall Disclosure Bulletin (TDB-ACC-NO: NN8801295), January 1988, US
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.